I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: M.S. - AF, Commissioner for MAY 2 1 20 Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

18 May 2004
Date of Deposit

Paul E. Rauch, Ph.D.
Name of Applicant, Assignee or Registered Representative

Signature

Our File No.: CYP01-002-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: H. Bamnolker et al.	)
Serial No.: 09/927,863	)
Filing Date: August 10, 2001	) Examiner: Lynette T. Umez-Eronini
For: METHODS OF FORMING SEMICONDUCTOR STRUCTURES HAVING REDUCED DEFECTS, AND ARTICLES AND DEVICES FORMED THEREBY	Group Art Unit No.: 1765 ) )

## PETITION AND FEE FOR EXTENSION OF TIME (37 CFR § 1.136(a))

M.S. - AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is a petition for an extension of the time to respond to the Office Action dated December 18, 2003 for a period of two months.

Please charge the \$420.00 fee to our American Express Card. A Credit Card Payment Form is attached. A duplicate copy of this Petition is attached.

05/24/2004 HALI11

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420.00 OP

Respectfully submitted,

Paul E. Rauch, Ph.D. Registration No. 38,591 Attorney for Applicant

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